

# “Characterization of laser-produced plasmas in the 1-6 nm region using cryogenic Xe targets”

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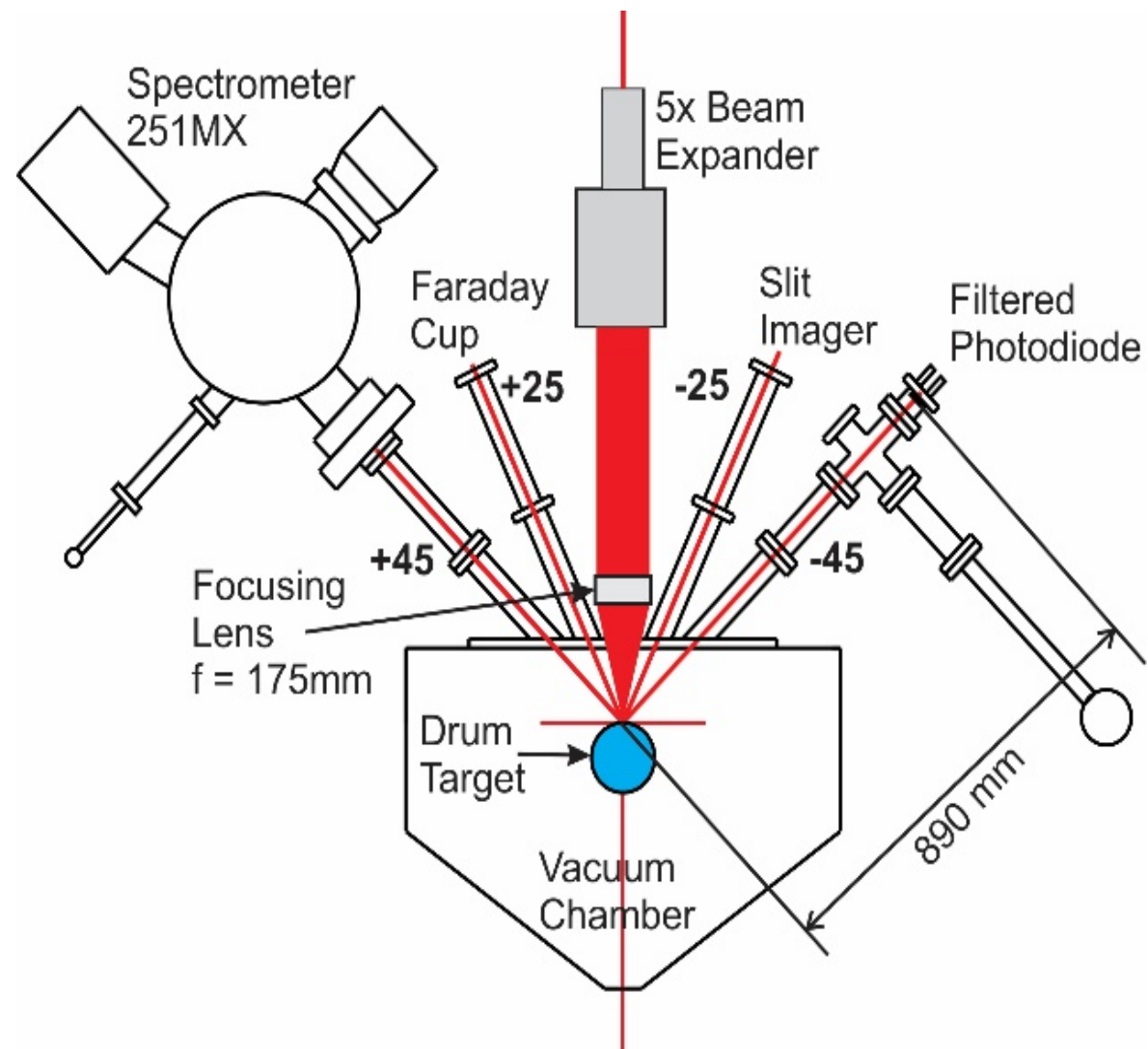
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# Experimental Set-up

**Ekspla 355SL** – 1064nm, 130-600ps up to ~300mJ on target (up to  $\sim 5 \times 10^{14}$  W/cm<sup>2</sup>)

**Quanta-Ray Pro** – 1064nm, 6.5ns, up to ~2 J on target (up to  $\sim 1 \times 10^{14}$  W/cm<sup>2</sup>)

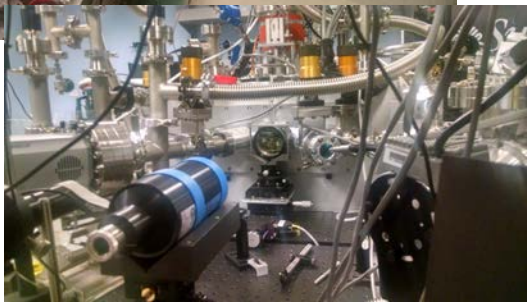


# Two target systems for cryogenic Xe

## LN2-cooled rotating drum

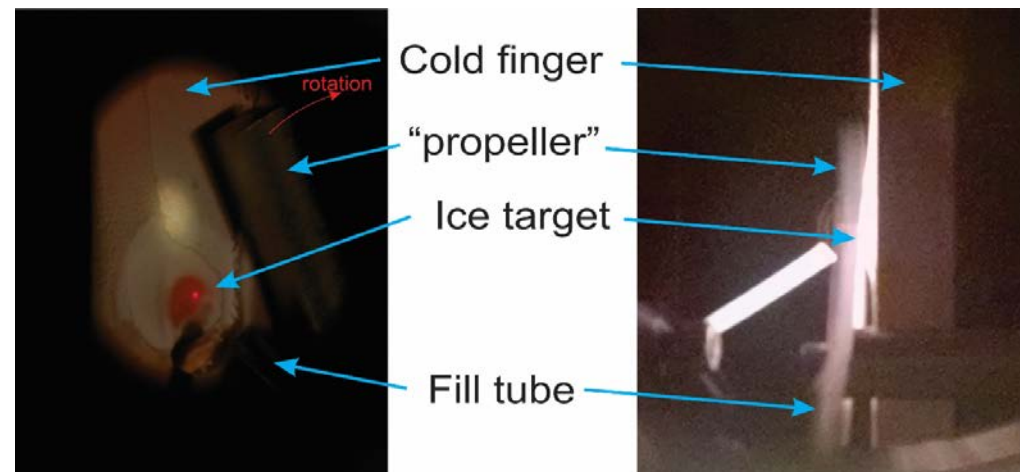
- Operates at 90 K with Xe flow 50-150 sccm
- Drum rotates at 100 rpm, and scans vertically
- 500 $\mu$ m thick mechanically-smoothed Xe ice layer

Fukugaki *et al*, *Rev. Sci. Instrum.*, **77**, 063114 (2006)



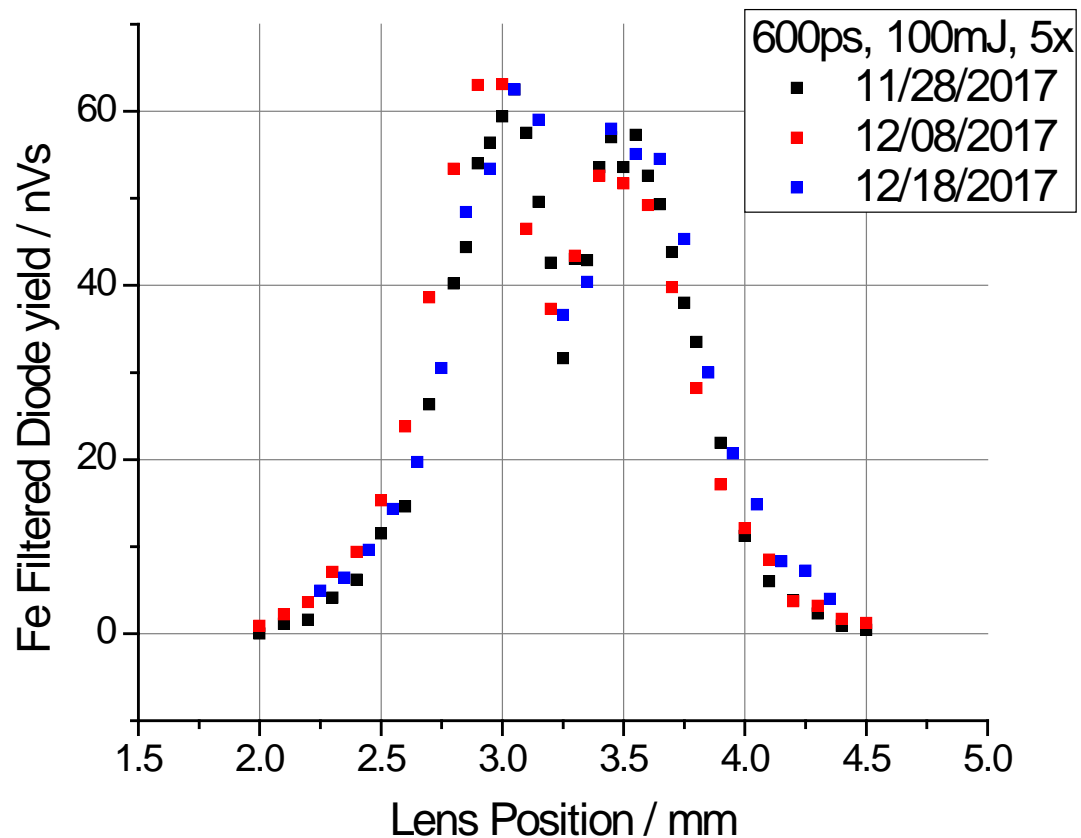
## LHe-cooled cold finger + propeller

- Typically cools to 50 K for expts (11 K possible)
- Ice forms in cavity, several mm thick
- Propeller blade rotates continuously and defines ice surface position
- Xe flow on to repair ice surface between shots (90 secs), and off for shots to specified vacuum level ( $< 5 \times 10^5$  torr)

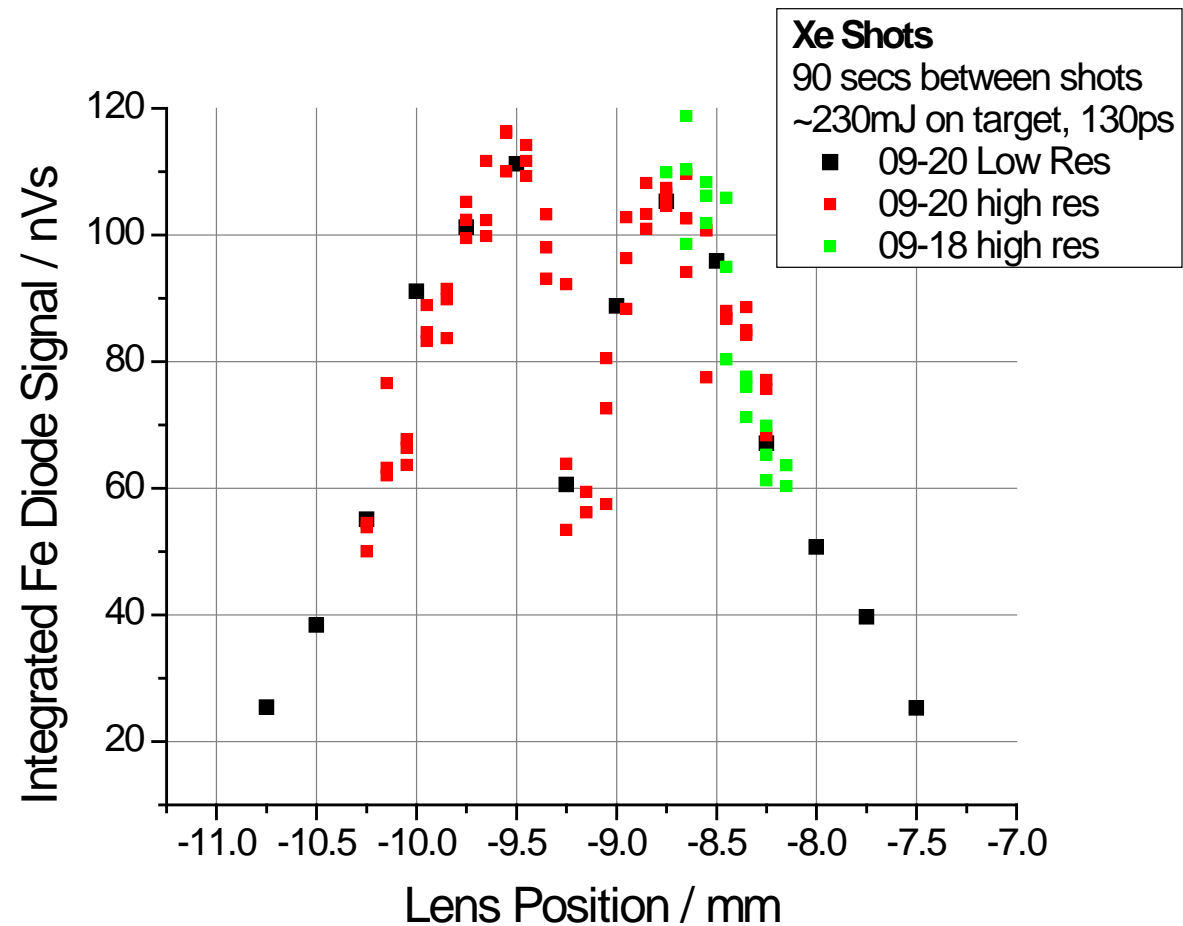


Amano *et al*, *Rev. Sci. Instrum.*, **85**, 063104 (2014)

# Both system show excellent repeatability of yield over the lens focusing range



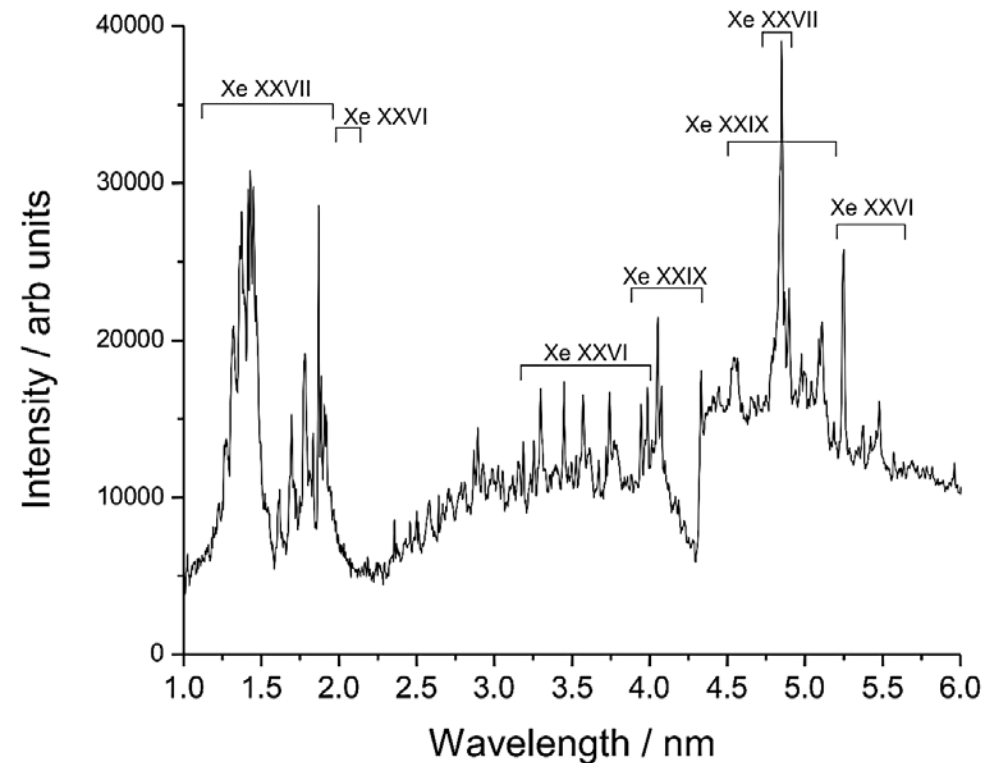
Drum Target



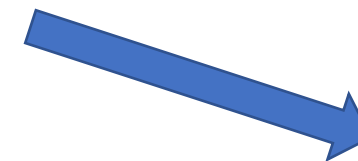
Propeller Target



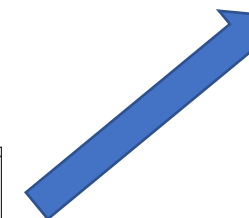
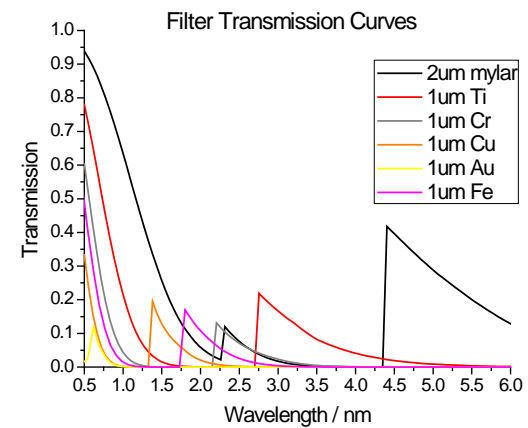
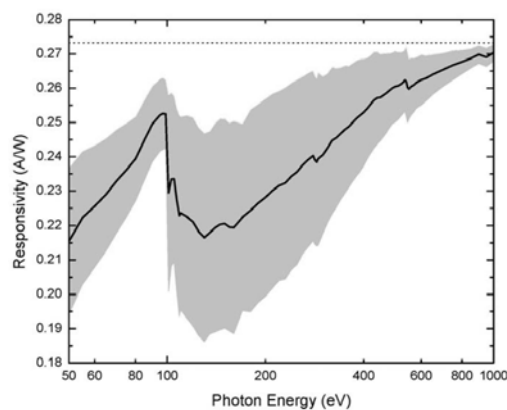
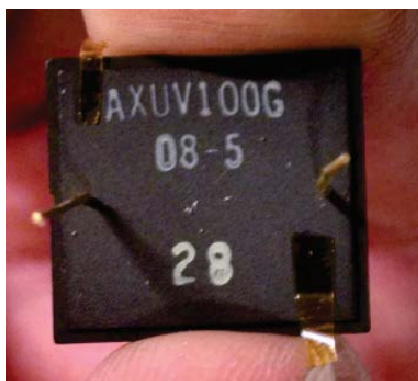
# Cross calibration of spectra with diode traces



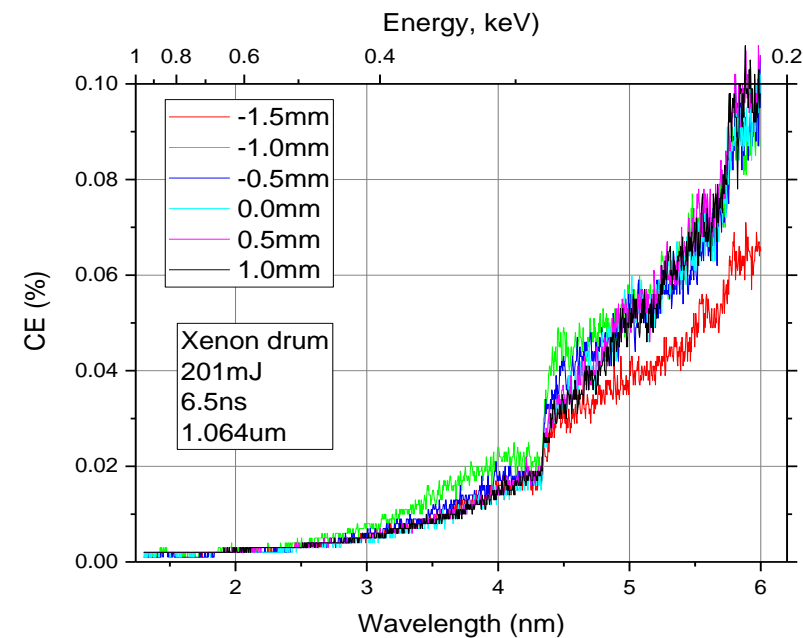
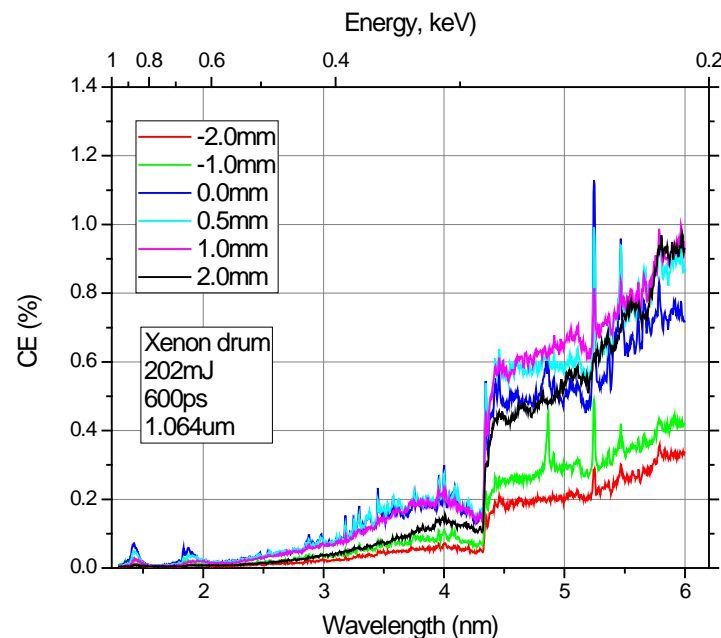
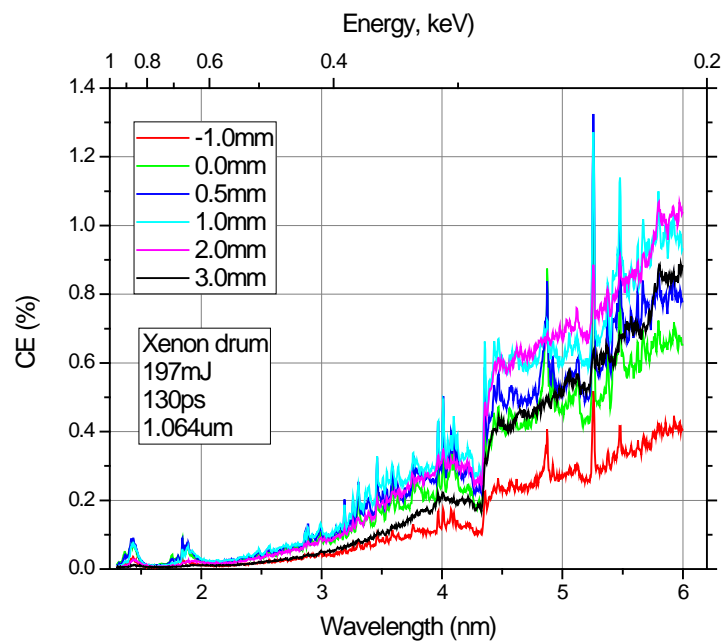
Grating Efficiency  
CCD Efficiency  
Filter transmission



Absolute  
Conversion  
Efficiency

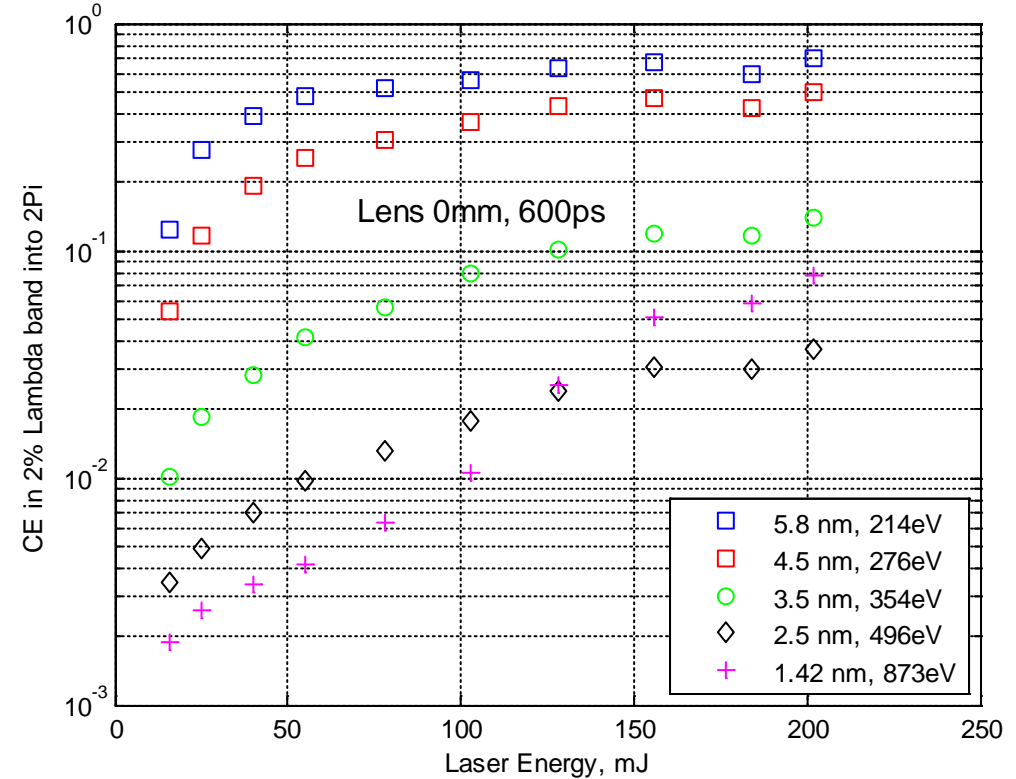
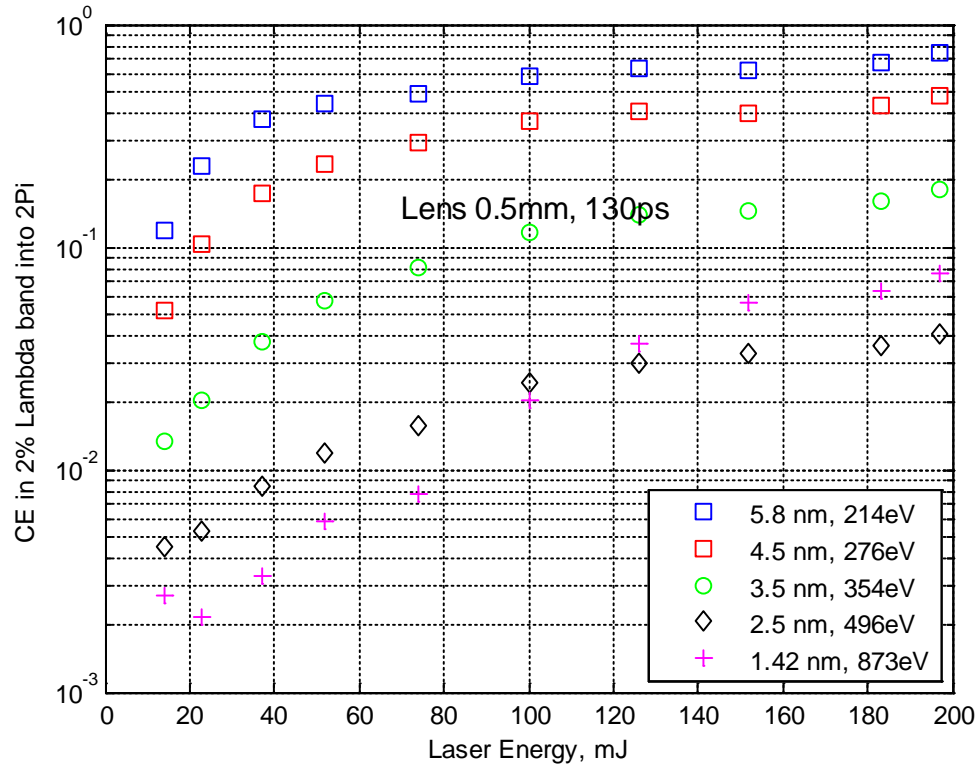


# Variation of Conversion Efficiency with Laser Pulse Length



- Maximum observed CE is about same for 130ps and 600ps pulses. Variation of CE with energy and beam spot is similar for both pulse durations.
- For 6.5ns pulse length, short wavelength (<3nm) lines, essentially eliminated
- Absolute CE at 6nm (~200eV) is about 1%
- For short wavelengths (1.4nm, 870eV) the best observed CE~0.08%

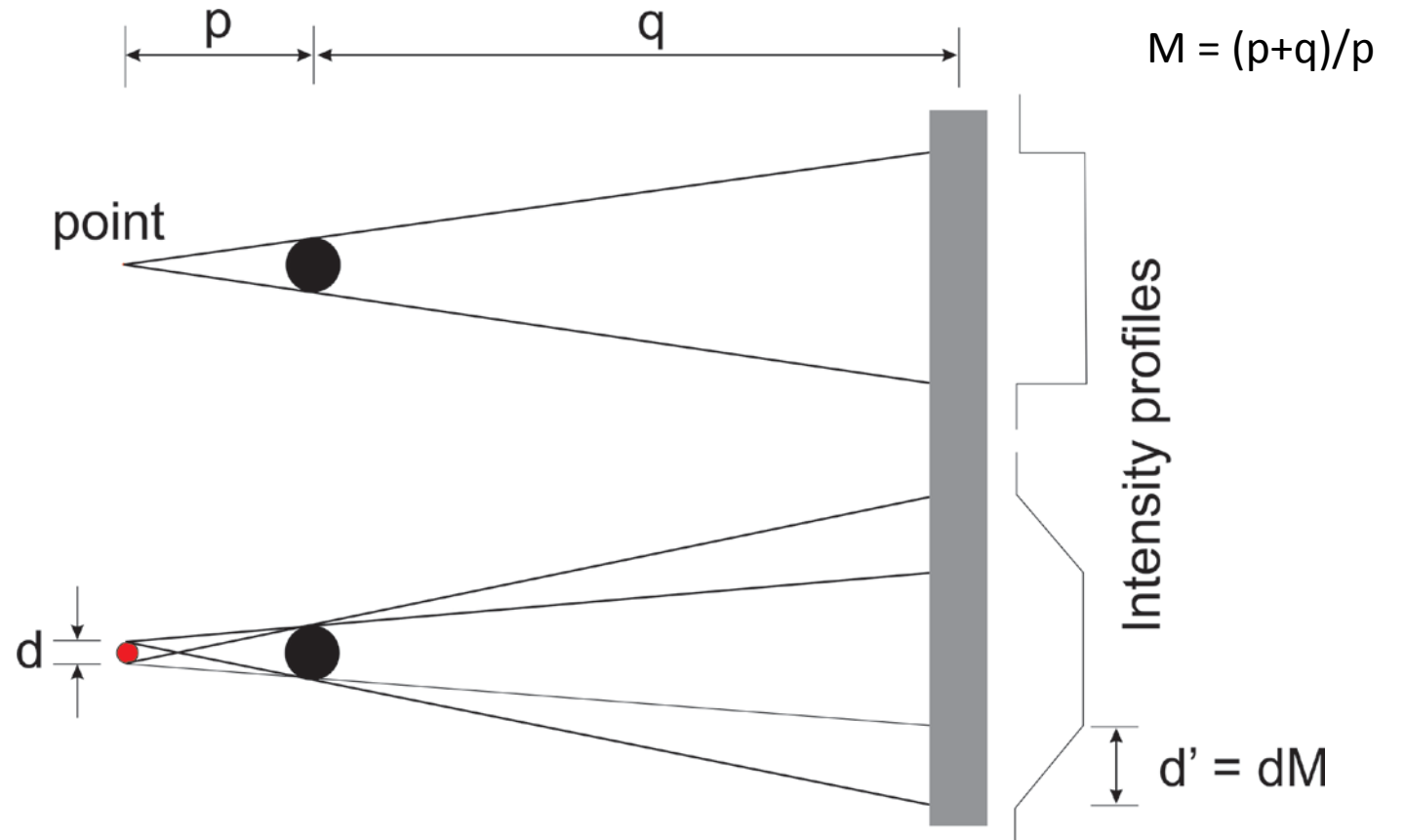
# Energy Requirements for peak conversion efficiencies



- Observed CE scales with incident laser energy – again similar trends for 130ps & 600ps
- Energy of >100mJ on target is required for achieving peak CE at shorter wavelength
- Energy of >200mJ on target is required for achieving peak CE at shorter wavelength

# Slit imager – point projection method

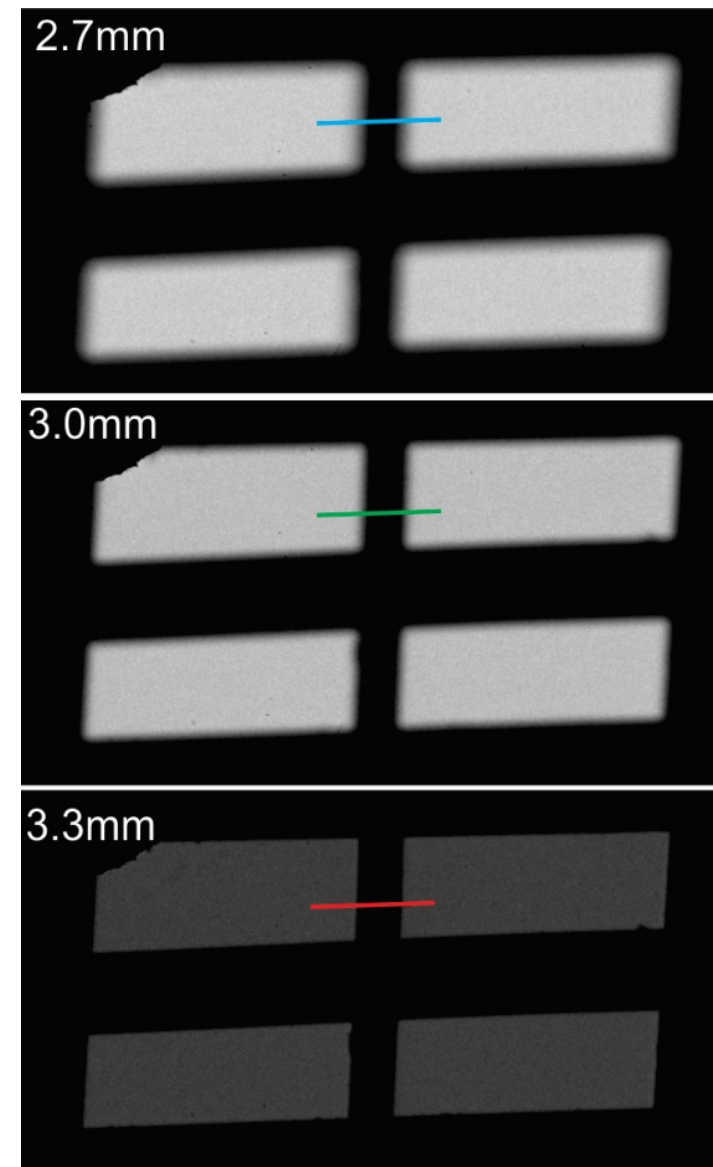
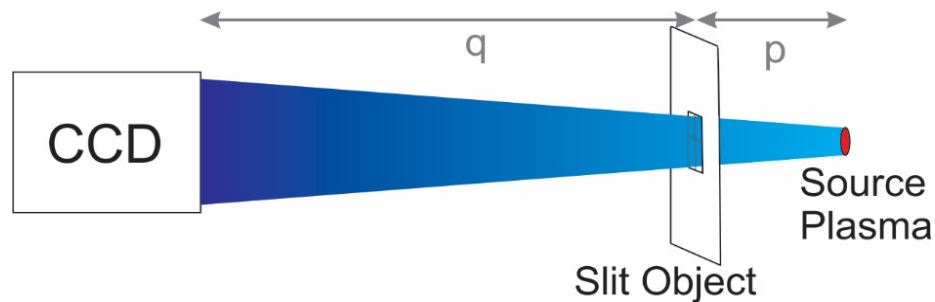
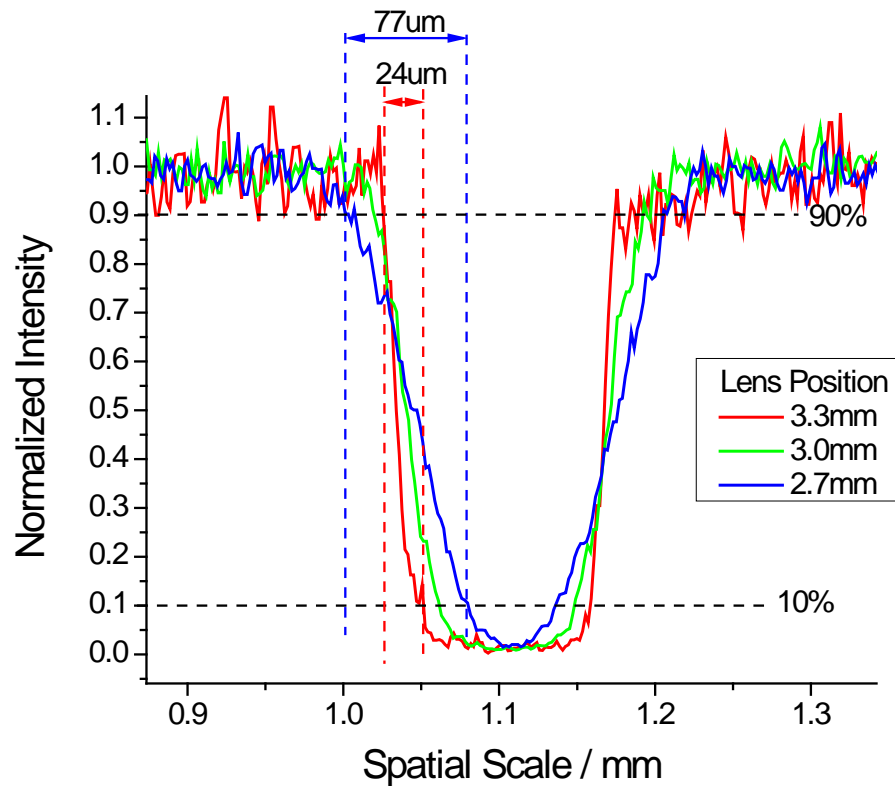
- Laser spot size is not necessarily the emission spot size, so measuring laser spot in may not be ideal, especially at higher intensities.
- Measuring the emission spot directly is more useful for metrology etc.
- Point projection backlighting can be used to directly measure the spot size, by measuring the edge spread of an edge imaged at high magnification



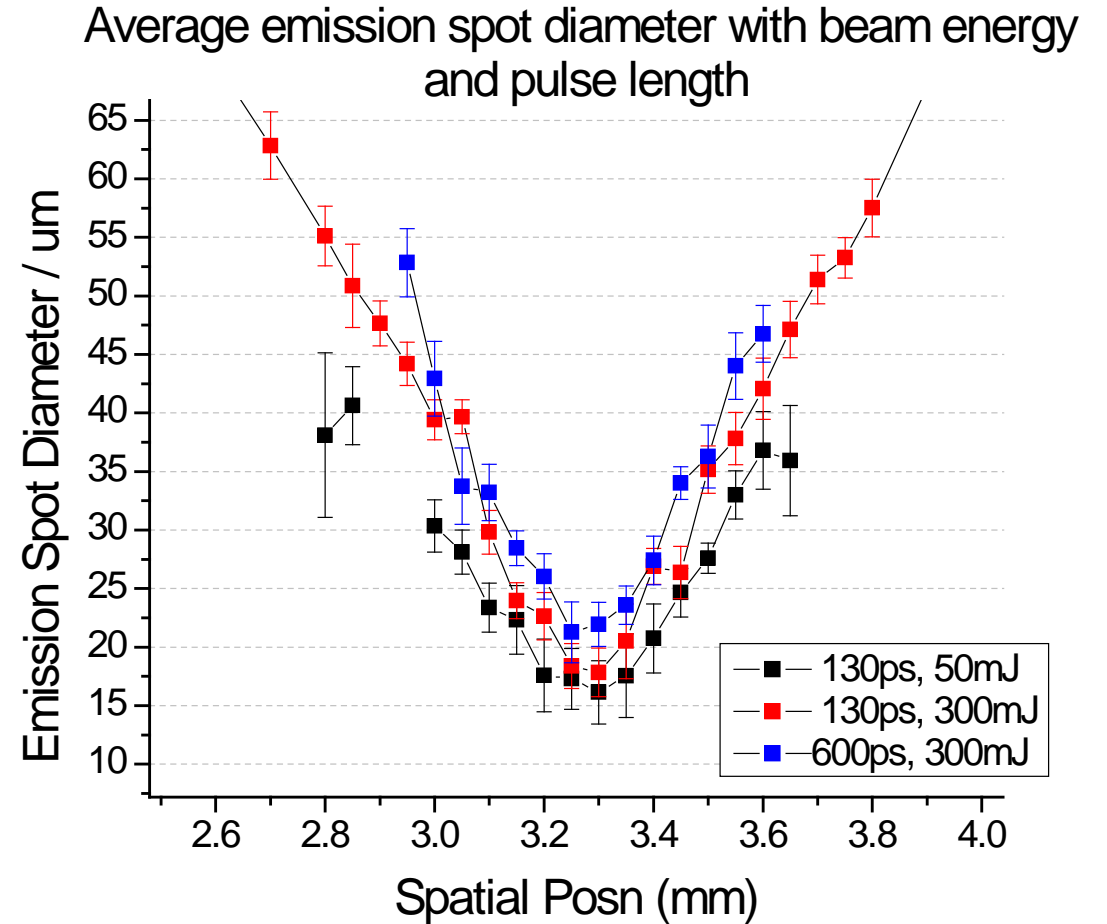
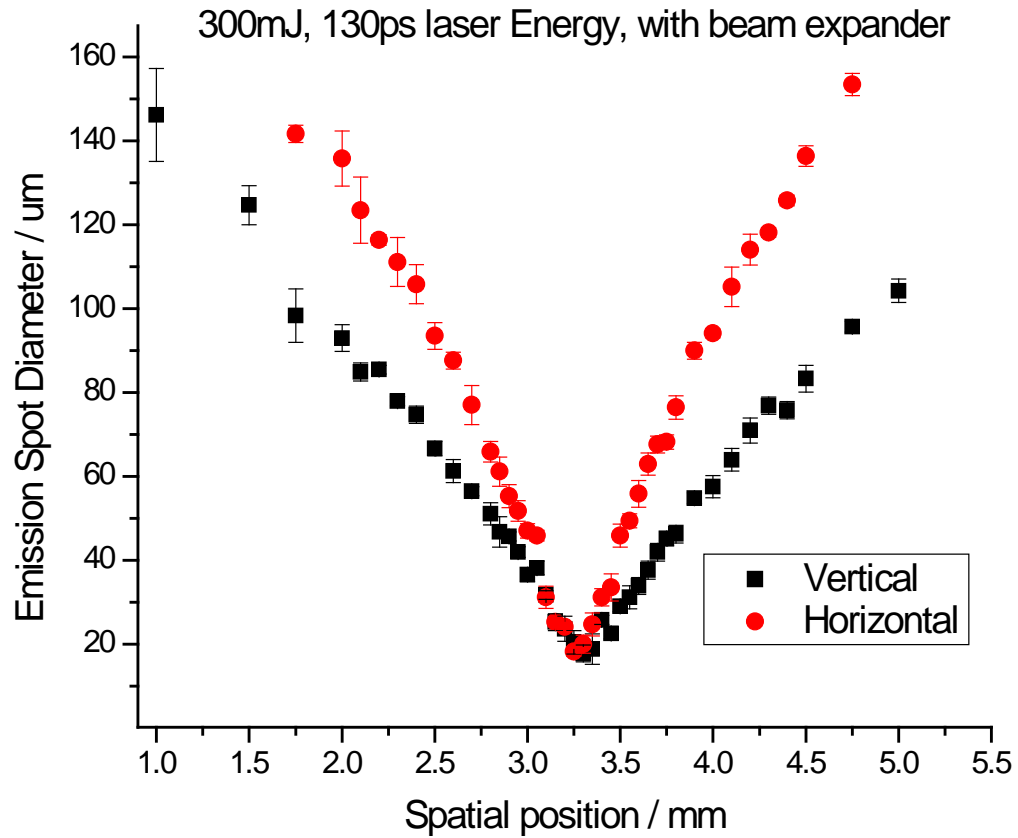


# Slit imager – data analysis

- Imaging target uses a ‘grid’ of wires to give multiple edge measurements
- Magnification = 6.2
- Errors dominated by determination of the magnification, and resolution across images (not better than 5%)



# Slit imager results



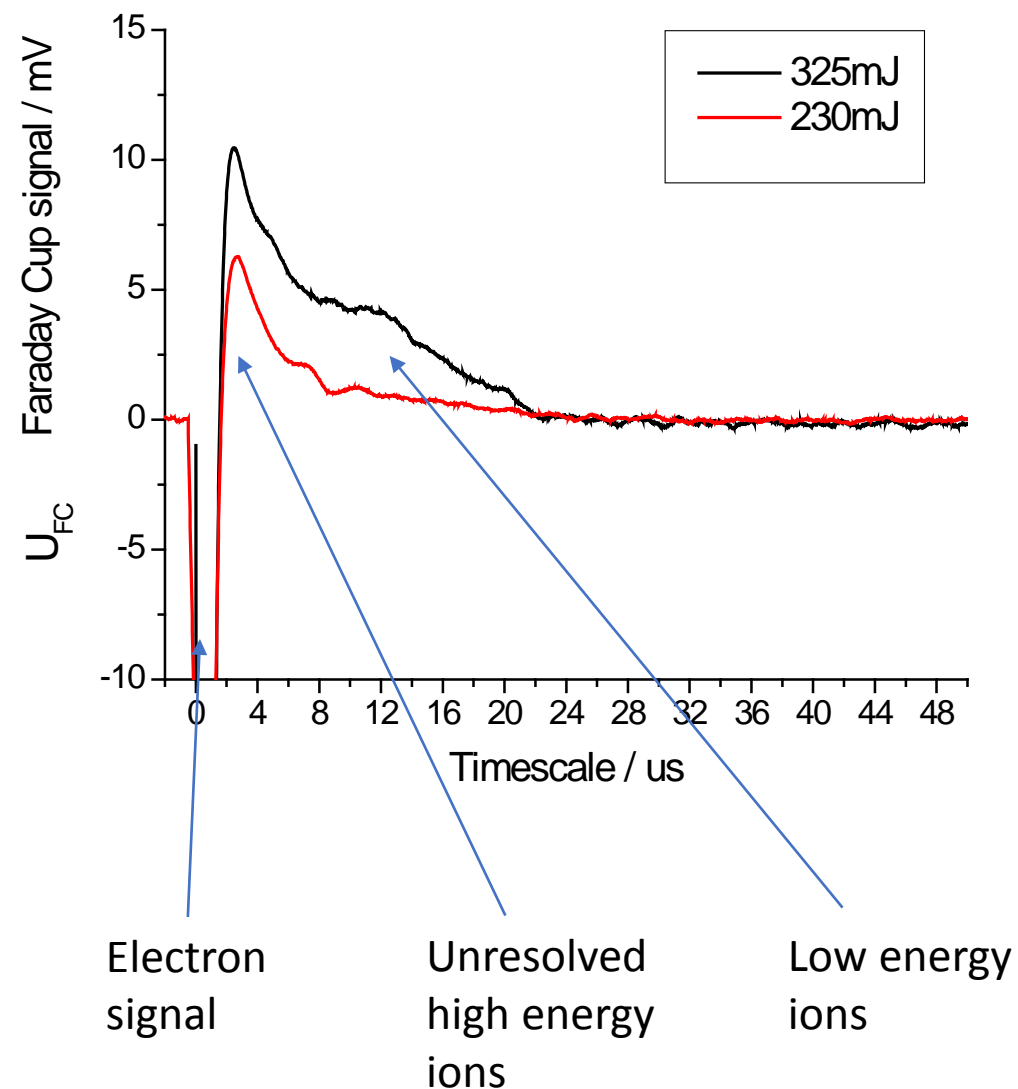
- Known beam asymmetry measured by slit images
- No clear trend with laser energy or pulse length

# Ion Spectra Measurements

- FC Set at 470 mm from the target.
- A voltage of 100 V was applied to the retarding grid and -30 V to the suppression grid
- Low energy ions only (i.e. long TOF) due to FC placement ( $E_{ion} < \text{few keV}$ )

$$\frac{dN}{dE} = - \frac{m_{ion}^{\frac{1}{2}} x}{(2E)^{\frac{3}{2}} R_{osc} Z e} U_{FC} \left( \sqrt{m_{ion} x^2 / 2 E} \right)$$

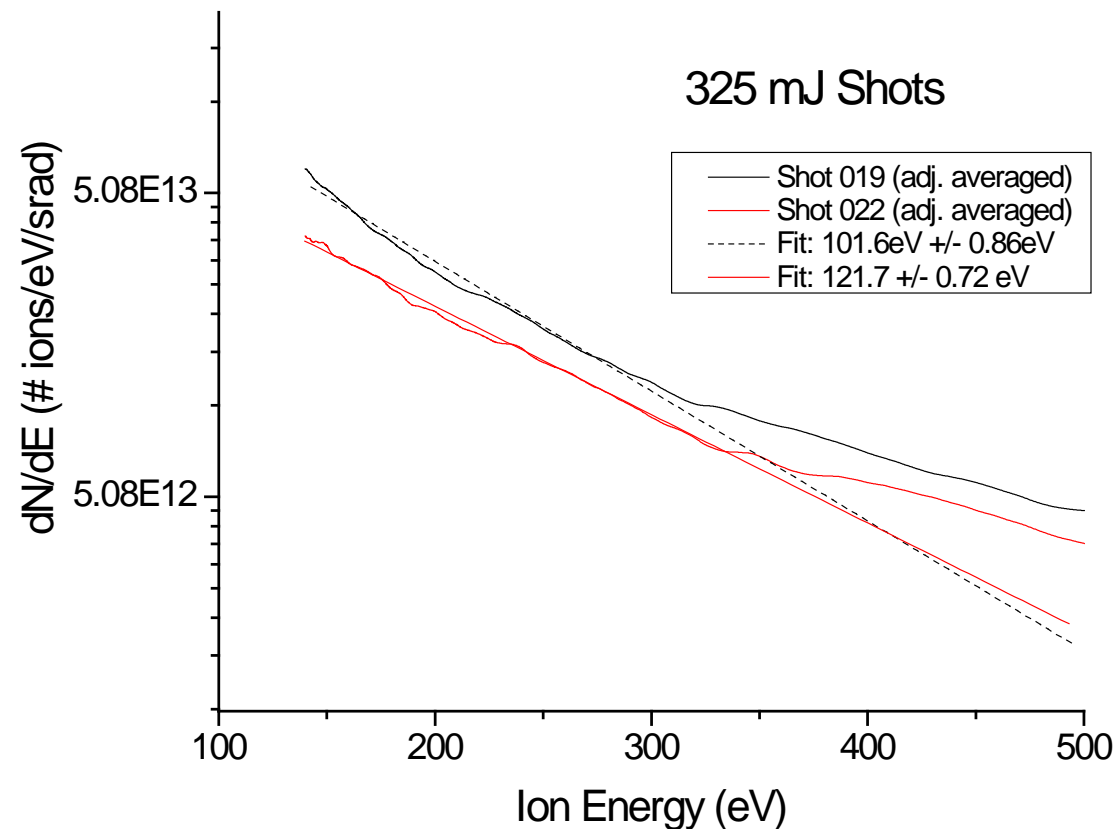
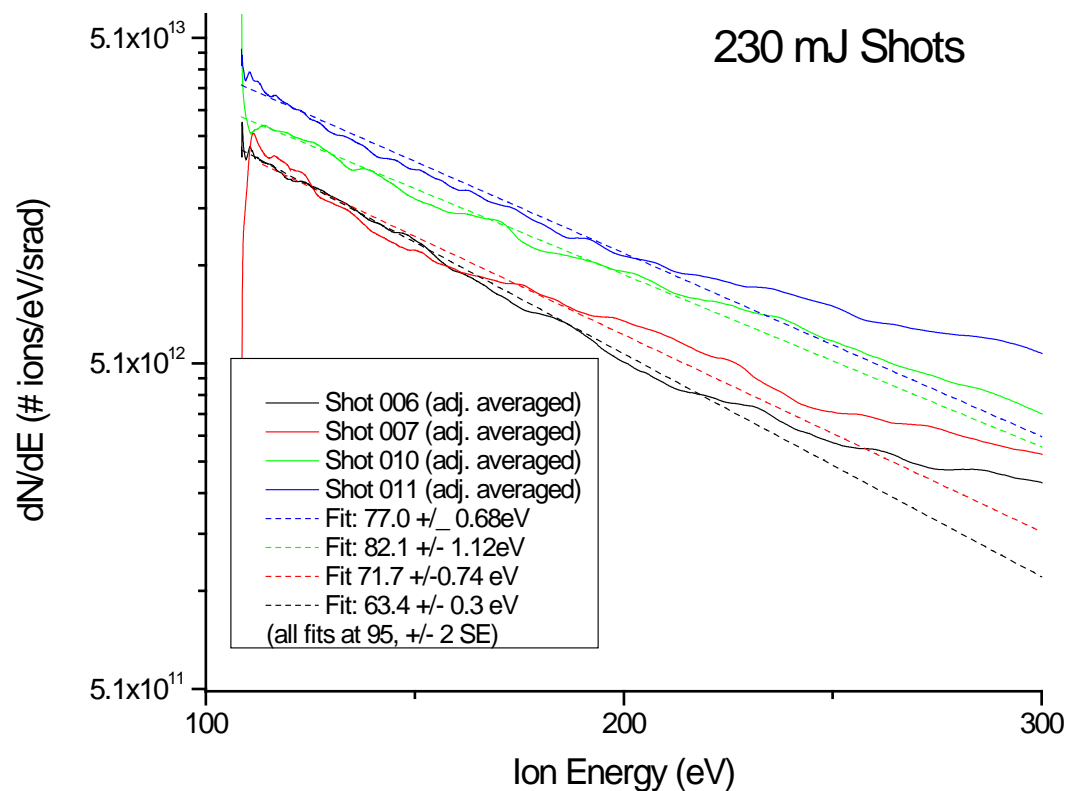
$$R_{osc} = 1k\Omega, x = 470mm, Z \text{ assumed to be } 5$$



# FC Data from drum target

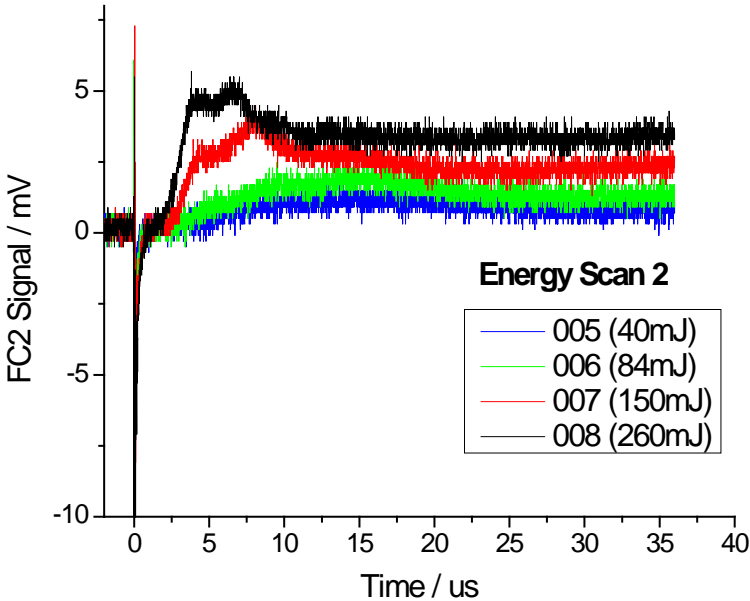
- The low energy distribution is close to linear, for the first decade drop in ion number
- This suggest a single temperature plasma that can be fit assuming a Maxwellian distribution covering the bulk of the ion population

$$\frac{dN}{dE} = A_0 e^{-E/kT}$$

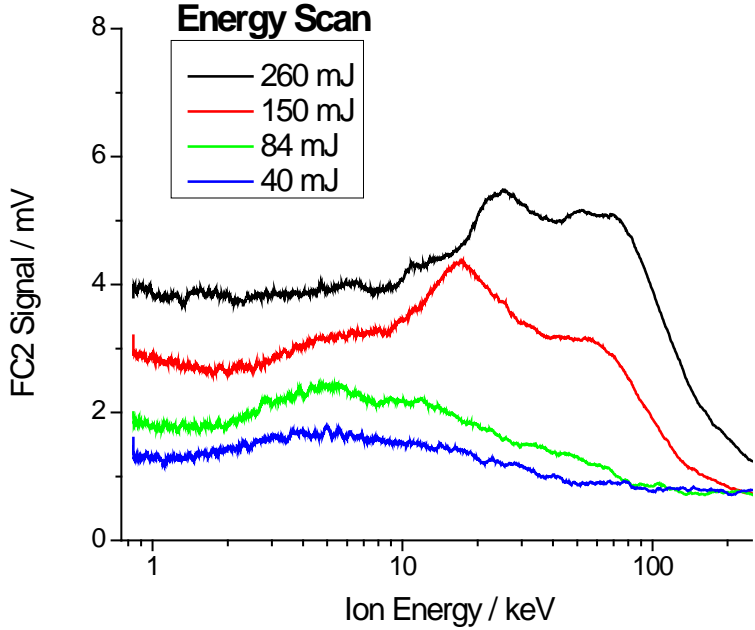


# FC Data from Propeller Target

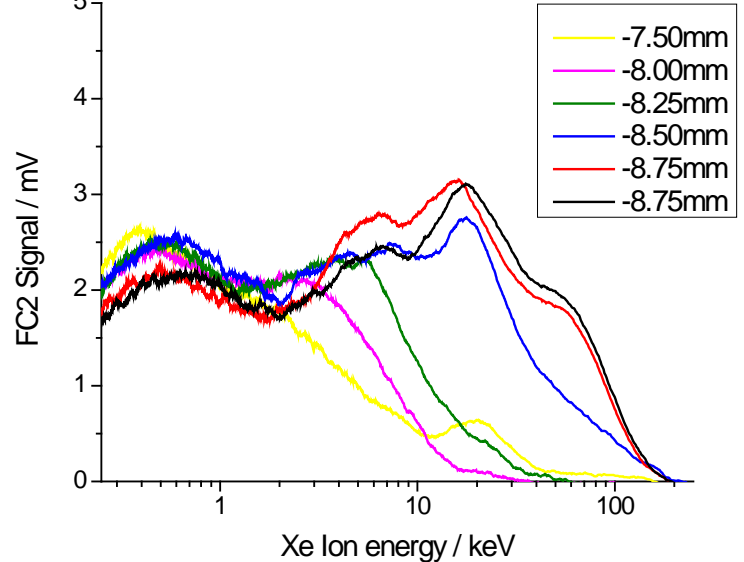
Raw Data



Ion Energy Plots



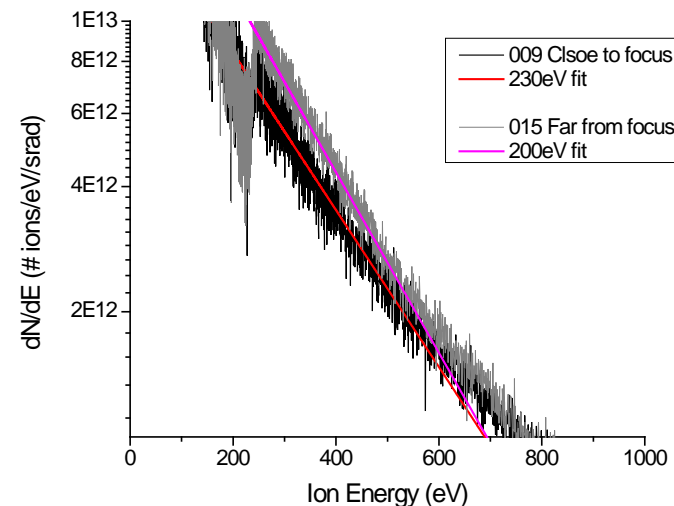
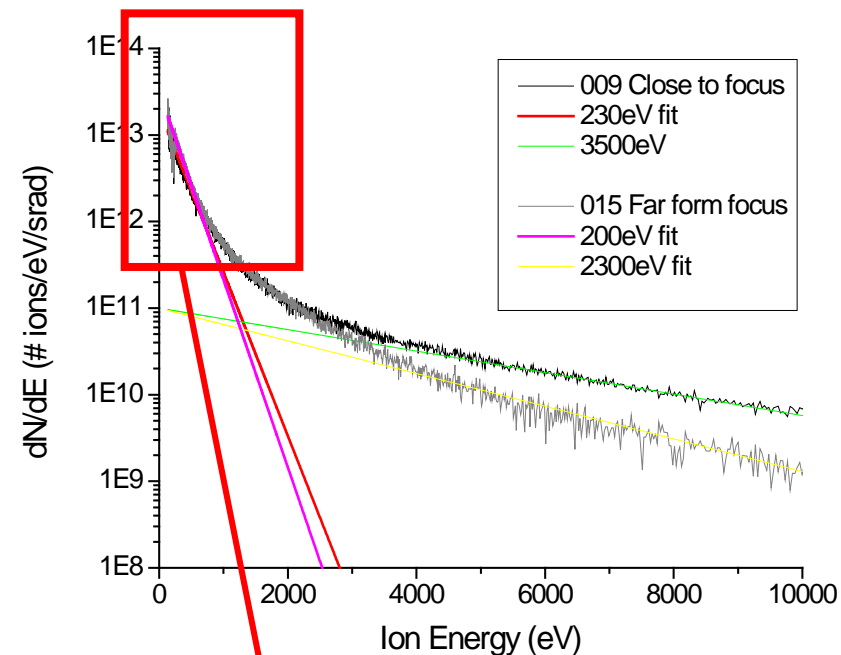
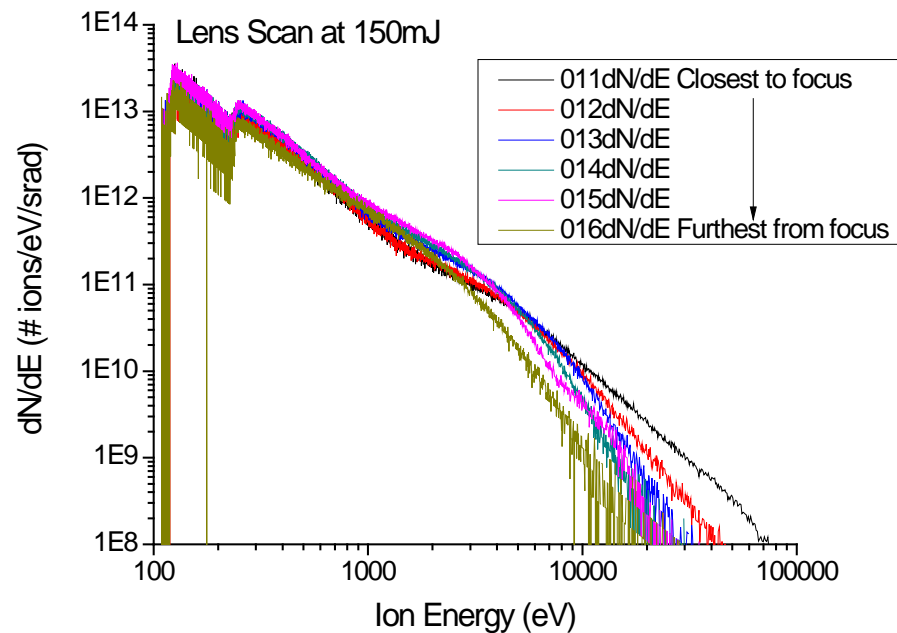
Lens Scan at 150mJ



- FC moved to 112cm to capture high energy spectrum
- Clear scaling with laser energy and focal position
- Energy spectrum shifts to higher energy with increasing intensity



# Propeller Target Temperature fits to ion spectrum



- Ion spectrum extends to 100keV, but populations drops rapidly with increasing energy
- Can use 2 temperature fit to characterize spectrum – probably an upper limit for bulk temperature
- Bulk of ions can again be described with a single temperature (~200eV). High Energy tail shows few keV ions
- Both values increase with laser intensity

# Conclusions

- ***The CE measurements are the first for Xe in 1-6nm range***
  - No strong effect of laser pulse length (intensity) at the same configuration (130ps vs 600ps)
  - Maximum conversion efficiency requires >100mJ on target
- ***Slit imager reports accurate dimensions of the emitting plasma directly, and is simple to implement and analyze***
  - Emission spot sizes <20 $\mu$ m observed
- ***The fits to the low energy ion spectra looks like a useful way to infer plasma temperature***
  - The fitted temperatures scale as expected with laser energy and focal position
  - Ion spectrum extends to very high energy (>100keV) but yield dominated by low energy (<1keV)
  - High energy tail strongly dependent on laser parameters
- ***Use of fitted temperatures from FC may allow recovery of density of the emitting plasma through spectral fitting***